



LIST OF CITATIONS BY APPLICANT (Use several sheets if necessary)	Atty. Docket No. 1673P1	10/627,776
	Applicant Stuart D. Hellring, et al.	
	Filing Date July 28, 2003	Group 1763

U.S. PATENT DOCUMENTS

Exam. Init.		Document No.	Date	Name	Class	Subclass	Filing Date if appropriate
gag	AA	5,720,551	02/24/98	T. Shechter	366	147	_____
	AB	5,904,159	05/18/99	H. Kato, et al.	134	7	_____
	AC	5,980,775	11/09/99	S.K. Grumbine, et al.	252	79.1	_____
gag	AD	6,136,711	10/24/00	S.K. Grumbine, et al.	438	692	_____
	AE						
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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation Yes No	
gag	AL	WO 00/39056	06.07.00	PCT	_____	_____	<input checked="" type="checkbox"/>	_____
	AM							
	AN							
	AO							
	AP							

OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

gag	AR	ASTM D 2414-93 "Standard Test Method for Carbon Black--n-Dibutyl Phthalate Absorption Number"
	AS	R.B. Anderson and P.H. Emmett, "Measurement of Carbon Black Particles by the Electron Microscope and Low Temperature Nitrogen Adsorption Isotherms", Journal of Applied Physics, Volume 19, April, 1948, pp. 367-373.
gag	AT	ASTM D 1993-91 "Standard Test Method for Precipitated Silica-Surface Area by Multipoint BET Nitrogen Adsorption"

Examiner George Goudreau	Date Considered 10-05'
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

AR	French Standard NF T 45-007, "Primary Materials for the Rubber Industry: Precipitated Hydrated Silica", Section 5.12, Method A, pp. 66-76, November 1987
AS	Lee M. Cook, "Chemical Processes in Glass Polishing", Journal of Non-Crystalline Solids, 1990, 120, 152-171
AT	Y. Li and S.V. Babu, "Chemical Mechanisms in CMP of Cu and Ta Using Silica Abrasives," Fifth Annual CMP Symposium 2000, August 14, 2000, Lake Placid, New York

Examiner George Goudreau	Date Considered 10-051
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SUBSTITUTE DISCLOSURE STATEMENT FORM (PTO 1449)

Atty. Docket No. 1673P1		10/627,776
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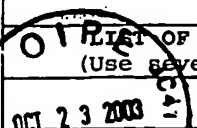
OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	Y. Li, A. Jindal and S.V. Babu, "Role of Chemicals and Abrasive Particle Properties in Chemical-Mechanical Polishing of Copper and Tantalum, Proc." The Electrochemical Society 198 th Meeting, Phoenix, Arizona, October 22-27, 2000
	AS	ASTM Standards, Method A of D-280, Volume 06.02 (Reapproved 1987) "Standard Test Methods for Hygroscopic Moisture (and Other Matter Volatile Under the Test Conditions) in Pigments"
	AT	John H. Perry, Chemical Engineers Handbook, 4 th Edition, McGraw-Hill Book Company, New York (1963), Library of Congress Catalog Card Number 6113168, pages 8-42 and 8-43

Examiner George Goudreau	Date Considered 10-051
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SUBSTITUTE DISCLOSURE STATEMENT FORM (PTO 1449)

	Atty. Docket No. 1963P1	10/627,776
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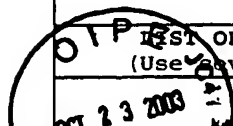
OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

gag	AR	Warren L. McCabe and Julian C. Smith, "Unit Operations of Chemical Engineering", 3 rd Edition, McGraw-Hill Book Company, New York (1976) ISBN 0-07-044825-6, pages 844-845
	AS	F.E. Albus, "The Modern Fluid Energy Mill," Chemical Engineering Progress, Volume 60, No. 6 (June 1964), pages 102-106
gag	AT	Ralph K. Iler, "The Chemistry of Silica," 1979 John Wiley & Sons, Inc., New York, Chapter 5

Examiner <i>George Goudreau</i>	Date Considered <i>10-05</i>
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OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

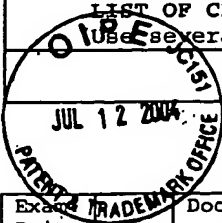
gfy	AR	U.S. Serial No: 09/882,548 filed 06/12/02 "A SILICA-BASED SLURRY"
gfy	AS	U.S. Serial No. 60/401,131 filed 08/05/02 "A SILICA-BASED SLURRY COMPOSITION"
gfy	AT	U.S. Serial No. 60/401,108 filed 08/05/02 "CMP COMPOSITION AND SLURRY"

Examiner <i>George Gaudreau</i>	Date Considered 10-051
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<u>gag</u>	AA	5,484,581	01/16/96	H. Esch, et al.	423	335	_____
<u>gag</u>	AB	6,063,306	05/16/00	V.B. Kaufman, et al.	252	79.4	_____
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	AH						
	AI						
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FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation Yes No	
<u>gag</u>	AL	WO 97/45366	04.12.97	PCT	_____	_____	_____	_____
<u>gag</u>	AM	WO 02/102910 A1	27.12.02	PCT	_____	_____	_____	_____
	AN							
	AO							
	AP							

OTHER CITATIONS (Including Author, Title, Date, Pertinent Pages, Etc.)

<u>gag</u>	AR	Silica and A Silica-Based Slurry, Stuart D. Hellring, et al., United States Patent Application Publication No. US 2003/0094593 A1
	AS	
	AT	

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